CLAIMS

1.	A spin va	aive trans	istor com	orising:	
an em	an emitter;				
a colle	ector;				
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- 5 a base between the emitter and the collector;
 - a spin valve including:
 - a ferromagnetic free layer structure;
 - a self-pinned antiparallel (AP) pinned layer structure; and
 - a nonmagnetic spacer layer between the free layer structure and the AP pinned layer structure; and

the base comprising at least said free layer structure.

2. A spin valve transistor as claimed in claim 1 wherein the base comprises the free layer structure, the self-pinned AP pinned layer structure and the spacer layer.

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- 3. A spin valve transistor as claimed in claim 1 wherein the base comprises the free layer structure, the emitter comprises the AP pinned layer structure and the spacer layer is located between the base and emitter.
- 20 4. A spin valve transistor as claimed in claim 1 wherein the self pinned AP pinned layer structure comprises:
 - a ferromagnetic first antiparallel (AP) pinned layer;
 - a ferromagnetic second antiparallel (AP) pinned layer;
- a nonmagnetic antiparallel coupling (APC) layer located between the first and second AP pinned layers;
 - one of the first and second AP pinned layers having a cobalt iron (CoFe) film with a positive magnetostriction; and

the CoFe film having a magnetostrictive anisotropy field that is oriented perpendicular to a head surface of the spin valve transistor for self pinning the AP pinned layer structure.

- 5 A spin valve transistor as claimed in claim 4 wherein the cobalt iron is $Co_{90-50}Fe_{10-50}$.
 - 6. A spin valve transistor as claimed in claim 4 wherein the first and second AP pinned layers have the same magnetic thickness.

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7. A spin valve transistor as claimed in claim 4 further comprising: the first AP pinned layer being composed of iron (Fe) and interfacing the spacer layer;

the second AP pinned layer including:

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an iron (Fe) film;

said cobalt iron (CoFe) film;

the iron (Fe) film being located between and interfacing the APC layer and the cobalt iron (CoFe) film; and

the free layer structure being composed of iron (Fe) and interfacing the spacer layer.

- 8. A spin valve transistor as claimed in claim 7 wherein the cobalt iron is $Co_{90-50}Fe_{10-50}$.
- 25 9. A spin valve transistor as claimed in claim 8 wherein the cobalt iron is Co₅₀Fe₅₀.
 - 10. A spin valve transistor as claimed in claim 9 wherein the first and second AP pinned layers have the same magnetic thickness.

11. A spin valve transistor as claimed in claim 4 further comprising: the second AP pinned layer being composed of iron (Fe); the first AP pinned layer including:

first and second iron (Fe) films with the first iron (Fe) film interfacing the spacer layer;

said cobalt iron (CoFe) film; and

the cobalt iron (CoFe) film being located between and interfacing the first and second iron (Fe) films.

- 10 12. A spin valve transistor as claimed in claim 11 wherein the cobalt iron film is Co₉₀₋₅₀Fe₁₀₋₅₀.
 - 13. A spin valve transistor as claimed in claim 12 wherein the cobalt iron film is $Co_{50}Fe_{50}$.

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14. A spin valve transistor as claimed in claim 13 wherein the first and second AP pinned layers have the same magnetic thickness.

15. A magnetic head assembly comprising:

a write head;

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a read head adjacent the write head;

the read head including:

ferromagnetic first and second shield layers; and

a spin valve transistor located between the first and second shield layers;

25 the spin valve transistor comprising:

an emitter;

a collector;

a base between the emitter and the collector;

a spin valve including:

- a ferromagnetic free layer structure;
- a self-pinned antiparallel (AP) pinned layer structure;
- a nonmagnetic spacer layer between the free layer structure and the AP pinned layer structure; and

the base comprising at least said free layer structure.

16. A magnetic head assembly as claimed in claim 15 wherein the self pinned AP pinned layer structure comprises:

a ferromagnetic first antiparallel (AP) pinned layer;

a ferromagnetic second antiparallel (AP) pinned layer;

a nonmagnetic antiparallel coupling (APC) layer located between the first and second AP pinned layers;

one of the first and second AP pinned layers having a cobalt iron (CoFe) film with a positive magnetostriction; and

the CoFe film having a magnetostrictive anisotropy field that is oriented perpendicular to a head surface of the spin valve transistor for self pinning the AP pinned layer structure.

17. A magnetic head assembly as claimed in claim 16 further comprising: the first AP pinned layer being composed of iron (Fe) and interfacing the spacer layer;

the second AP pinned layer including:

an iron (Fe) film;

said cobalt iron (CoFe) film;

the iron (Fe) film being located between and interfacing the APC layer and the cobalt iron (CoFe) film; and

the free layer structure being composed of iron (Fe) and interfacing the spacer layer.

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- 18. A magnetic head assembly as claimed in claim 17 wherein the cobalt iron is $Co_{90-50}Fe_{10-50}$.
- 19. A magnetic head assembly as claimed in claim 18 wherein the cobalt 5 iron is Co₅₀Fe₅₀.
 - 20. A magnetic head assembly as claimed in claim 19 wherein the first and second AP pinned layers have the same magnetic thickness.
- 21. A magnetic head assembly as claimed in claim 16 further comprising: the second AP pinned layer being composed of iron (Fe); the first AP pinned layer including:

first and second iron (Fe) films with the first iron (Fe) film interfacing the spacer layer;

said cobalt iron (CoFe) film; and

the cobalt iron (CoFe) film being located between and interfacing the first and second iron (Fe) film.

- 22. A magnetic head assembly as claimed in claim 21 wherein the cobalt 20 iron film is Co₉₀₋₅₀Fe₁₀₋₅₀.
 - 23. A magnetic head assembly as claimed in claim 22 wherein the cobalt iron film is $Co_{50}Fe_{50}$.
- 25 **24.** A magnetic head assembly as claimed in claim 23 wherein the first and second AP pinned layers have the same magnetic thickness.

25. A magnetic disk drive comprising:

at least one magnetic head assembly that has a head surface;

the magnetic head assembly having a write head and a read head;

the read head including:

5 ferromagnetic first and second shield layers; and

a spin valve transistor located between the first and second shield layers;

the spin valve transistor comprising:

an emitter;

a collector;

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a base between the emitter and the collector;

a spin valve including:

a ferromagnetic free layer structure;

a self-pinned antiparallel (AP) pinned layer structure;

a nonmagnetic spacer layer between the free layer structure and the AP

15 pinned layer structure; and

the base comprising at least said free layer structure;

a housing;

a magnetic medium supported in the housing;

a support mounted in the housing for supporting the magnetic head assembly with said head surface facing the magnetic medium so that the magnetic head assembly is in a transducing relationship with the magnetic medium;

a motor for moving the magnetic medium; and

a processor connected to the magnetic head assembly and to the motor for exchanging signals with the magnetic head assembly and for controlling movement of the

25 magnetic medium.

- **26.** A magnetic disk drive as claimed in claim 25 wherein the self pinned AP pinned layer structure comprises:
 - a ferromagnetic first antiparallel (AP) pinned layer;
 - a ferromagnetic second antiparallel (AP) pinned layer;
- a nonmagnetic antiparallel coupling (APC) layer located between the first and second AP pinned layers;

one of the first and second AP pinned layers having a cobalt iron (CoFe) film with a positive magnetostriction; and

the CoFe film having a magnetostrictive anisotropy field that is oriented perpendicular to a head surface of the spin valve transistor for self pinning the AP pinned layer structure.

27. A magnetic disk drive as claimed in claim 26 further comprising:
the first AP pinned layer being composed of iron (Fe) and interfacing the spacer
layer;

the second AP pinned layer including:

an iron (Fe) film;

said cobalt iron (CoFe) film; the iron (Fe) film being located between and interfacing the APC layer and the cobalt iron (CoFe) film; and

20 the free layer structure being composed of iron (Fe) and interfacing the spacer layer.

- 28. A magnetic disk drive as claimed in claim 27 wherein the cobalt iron is $Co_{90-50}Fe_{10-50}$.
- 29. A magnetic disk drive as claimed in claim 28 wherein the cobalt iron is $Co_{50}Fe_{50}$.

- 30. A magnetic disk drive as claimed in claim 29 wherein the first and second AP pinned layers have the same magnetic thickness.
- 31. A magnetic disk drive as claimed in claim 26 further comprising: the second AP pinned layer being composed of iron (Fe); the first AP pinned layer including:

first and second iron (Fe) films with the first iron (Fe) layer film interfacing the spacer layer;

said cobalt iron (CoFe) film; and

the cobalt iron (CoFe) film being located between and interfacing the first and second iron (Fe) film.

- 32. A magnetic disk drive as claimed in claim 31 wherein the cobalt iron is $Co_{90-50}Fe_{10-50}$.
- 33. A magnetic disk drive as claimed in claim 32 wherein the cobalt iron is $Co_{50}Fe_{50}$.
- 34. A magnetic disk drive as claimed in claim 33 wherein the first and second AP pinned layers have the same magnetic thickness.

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